

## Application Data Sheet

### **Application Information**

Application number:: Not Yet Assigned  
Application Type:: Regular  
Subject Matter:: Utility  
Suggested Group Art Unit:: N/A  
CD-ROM or CD-R?:: None  
Sequence submission?:: None  
Computer Readable Form (CRF)?:: No  
Title:: METHOD FOR REMOVING A RESIST MASK  
WITH HIGH SELECTIVITY TO A CARBON  
HARD MASK USED FOR SEMICONDUCTOR  
STRUCTURING  
Attorney Docket Number:: 543822003300  
Request for Early Publication?:: No  
Request for Non-Publication?:: No  
Small Entity?:: No  
Petition included?:: No  
Secrecy Order in Parent Appl.?:: No

### **Applicant Information**

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: India  
Status:: Full Capacity  
Given Name:: Srivatsa  
Family Name:: KUNDALGURKI  
City of Residence:: Dresden  
Country of Residence:: Germany  
Street of mailing address:: Theodor-Fontane-Straße 5  
City of mailing address:: Dresden  
Country of mailing address:: Germany  
Postal or Zip Code of mailing address:: D-01109

**Correspondence Information**

Correspondence Customer Number:: 25227

**Representative Information**

Representative Customer Number:: 25227

**Assignee Information**

Assignee name:: Infineon Technologies AG  
Street of mailing address:: St.-Martin Strasse 53  
City of mailing address:: München  
Country of mailing address:: Germany  
Postal or Zip Code of mailing address:: 81669